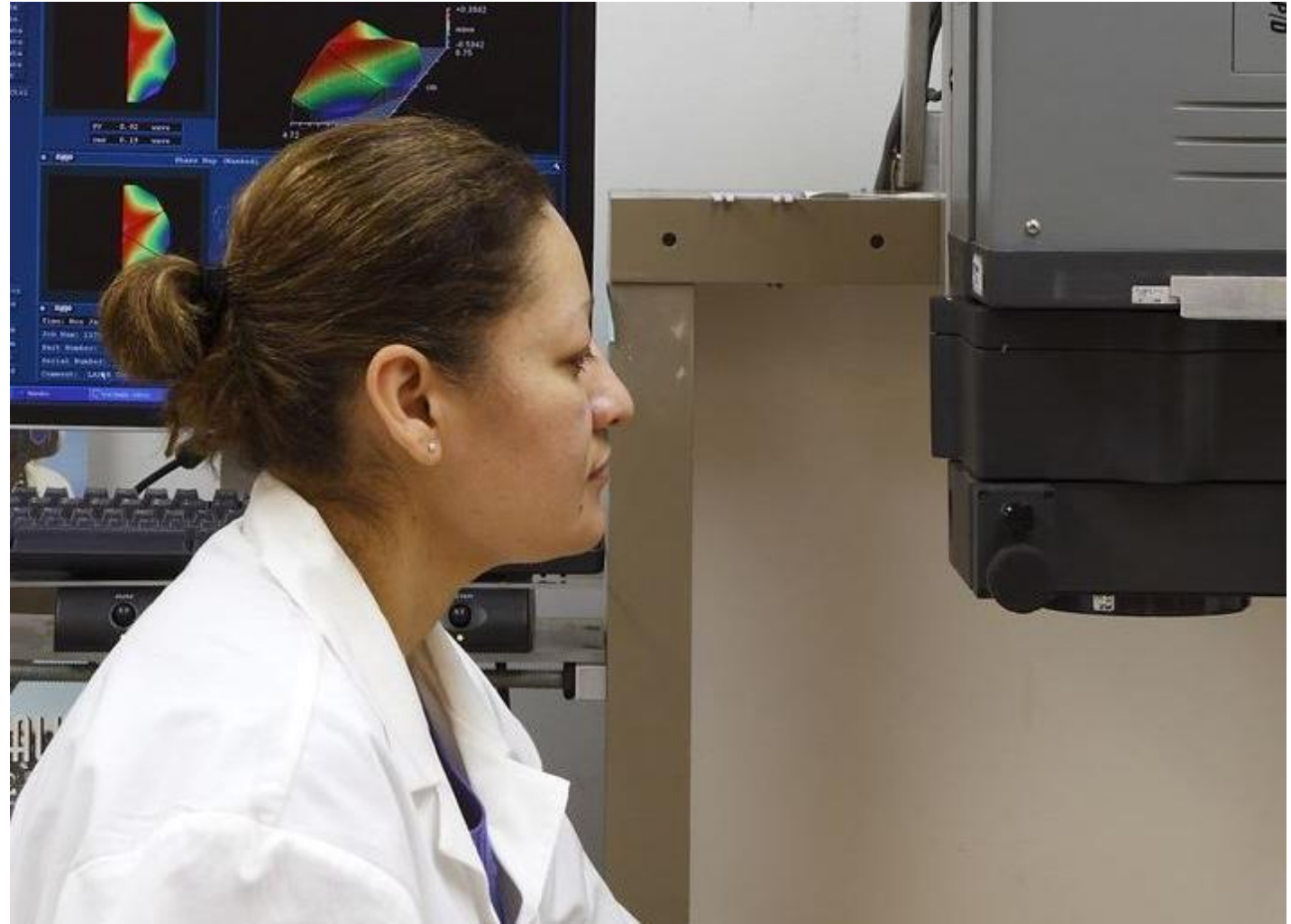


Disruptive Laser Metrology in Robotics

WWW.PLXinc.com
Malcolm Humphrey –
Program Director Active Optics



- Who is PLX inc?
- State of the art Monolithic Optical Structure Technology
- PLX acquire Reflex imaging
- Active Optics in PLX





1975
NASA Apollo
Soyuz gas
measurement



1985
Abrams
Tank
M1A1



1995
Bradley
IBAS TOW
Missile
ITAS



2005
Apache
Helicopter
AH-64D



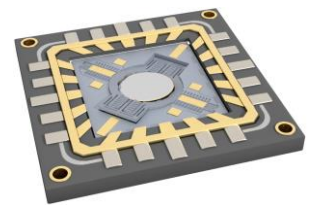
2015 Army
Common
Sensor
Payload
(CSP)



2010
Apache
Helicopter
AH-64E

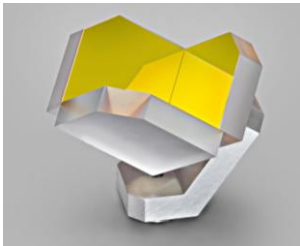


2020
Creation
of
Active
optics



1955
PLX
founded

1970
Invention
on
Hollow
retro-
reflector



1985
NASA long
distance
laser test



1990
NASA
Atmospheric
& mirror
projects



2000
M.O.S.T
invented

Monolithic Optical Structure Technology (M.O.S.T)

- All of the elements of a complex optical setup into a single monolithic unit.
- Superb optical stability, unsurpassed shock and vibration resistance.
- Sub-arc second accuracy between optical elements.
- Integrates different glass types and exotic materials such as KBr, ZnSe and CaF₂, into one assembly.
- Permanently aligned so you will never need to adjust it and also lasts indefinitely.
- Use in interferometer configurations, laser cavities, beam dividers, beam delivery systems, Boresighting and more.





PLX Acquire Reflex Imaging

Reflex Imaging approaches PLX

Suggested collaboration with the Monolithic Optical-Structure Technology™ (M.O.S.T™) and the O-LAMM metrology system.

PLX acquires Reflex outright

Both companies quickly identified synergies between PLX and Reflex imaging's technology and expertise.

Future technology

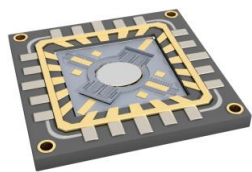
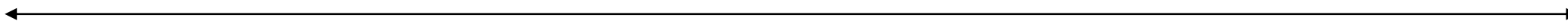
The collaboration has already yielded the new technologies that combine the best of both companies expertise

What's new: Active Optics and Systems

MEMS based active optical devices

Industrial Metrology Systems

Electronic and electro-optic systems

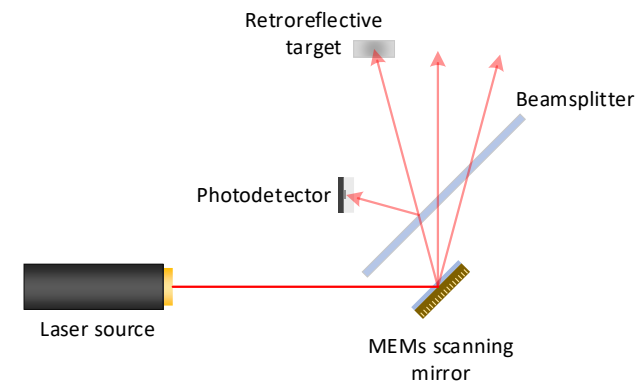


MEMs scanning mirror

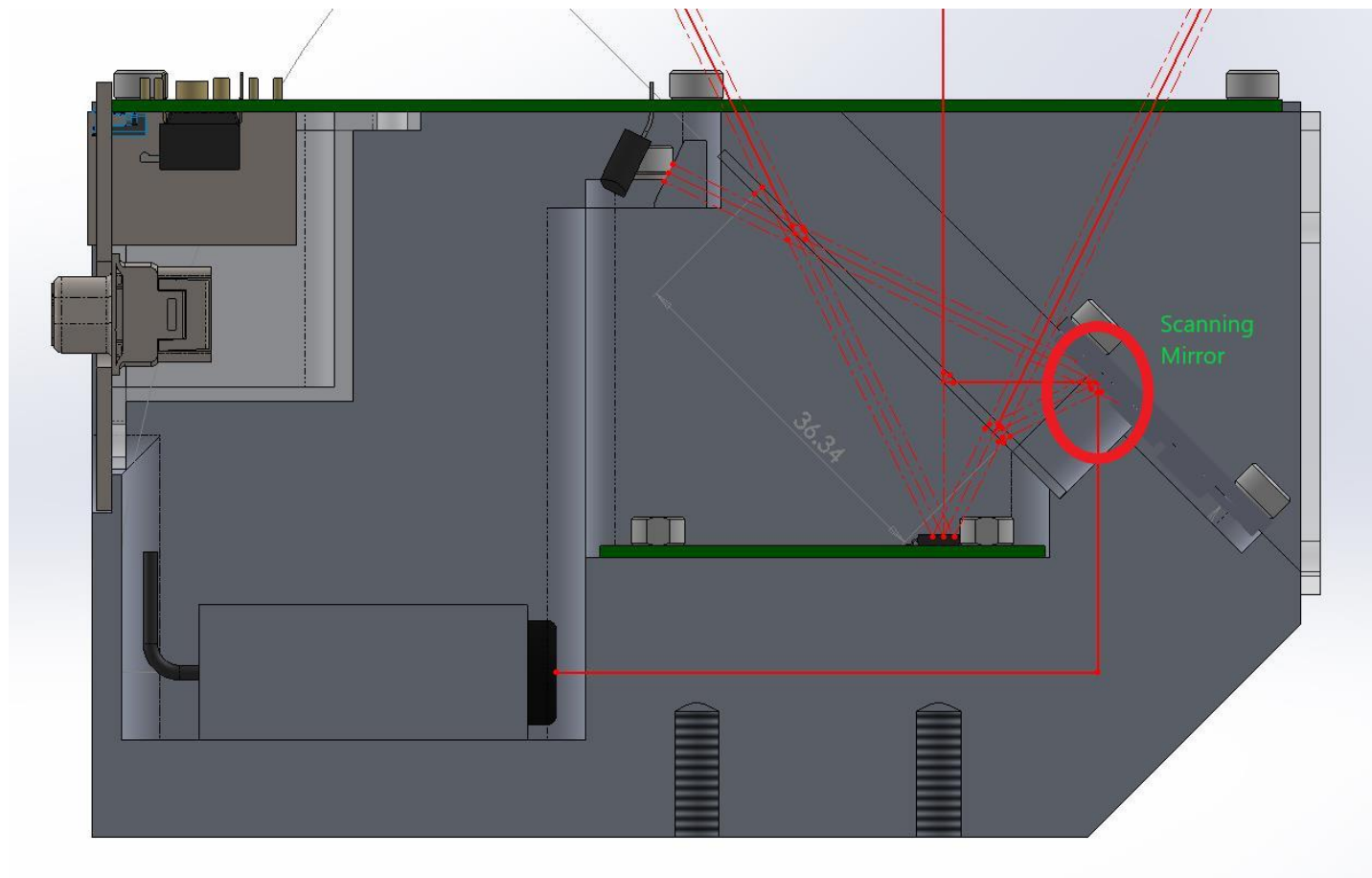


LAMM scanning laser tracker

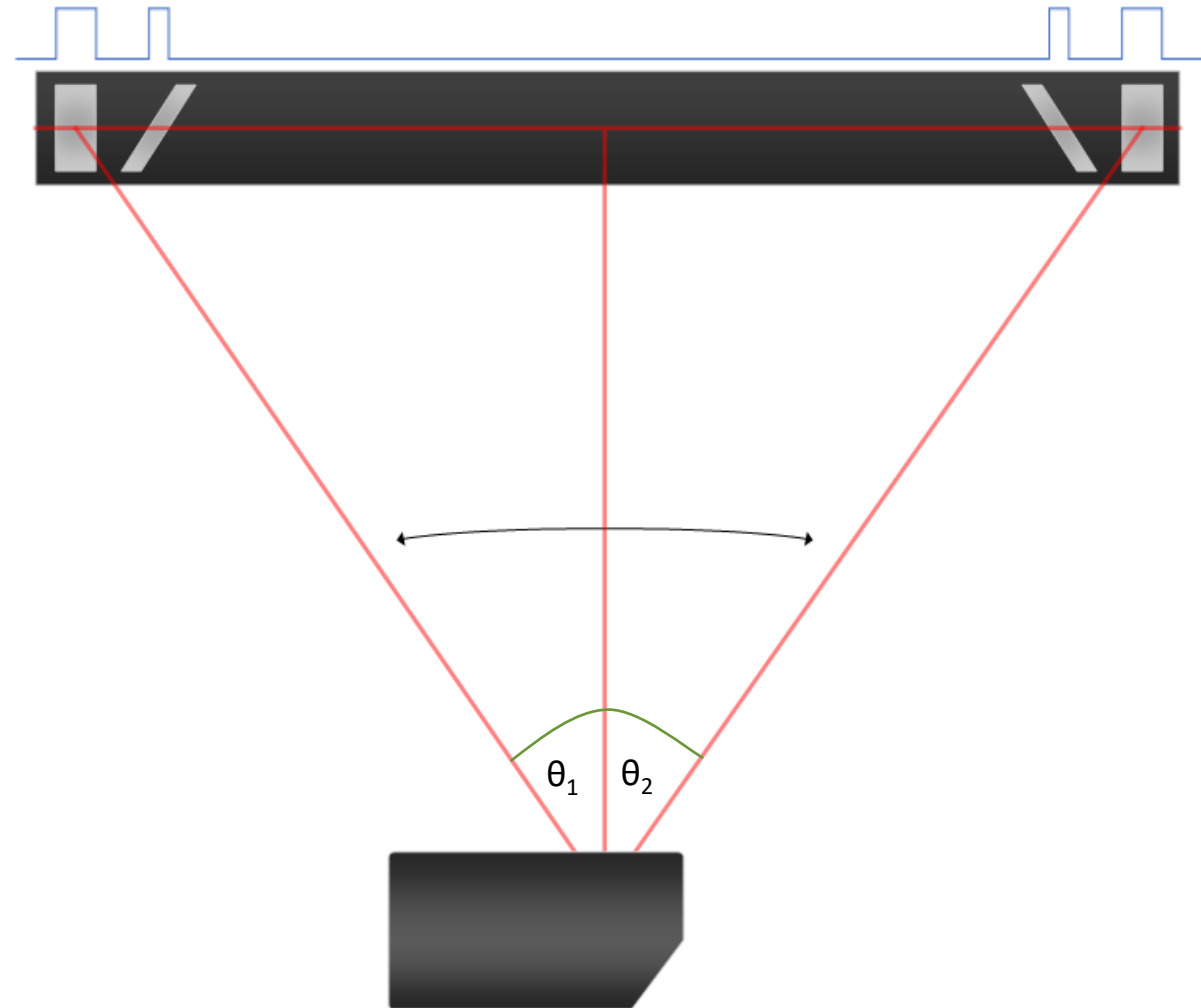
Simplified Optical layout of scanning laser tracker



LAMM optics



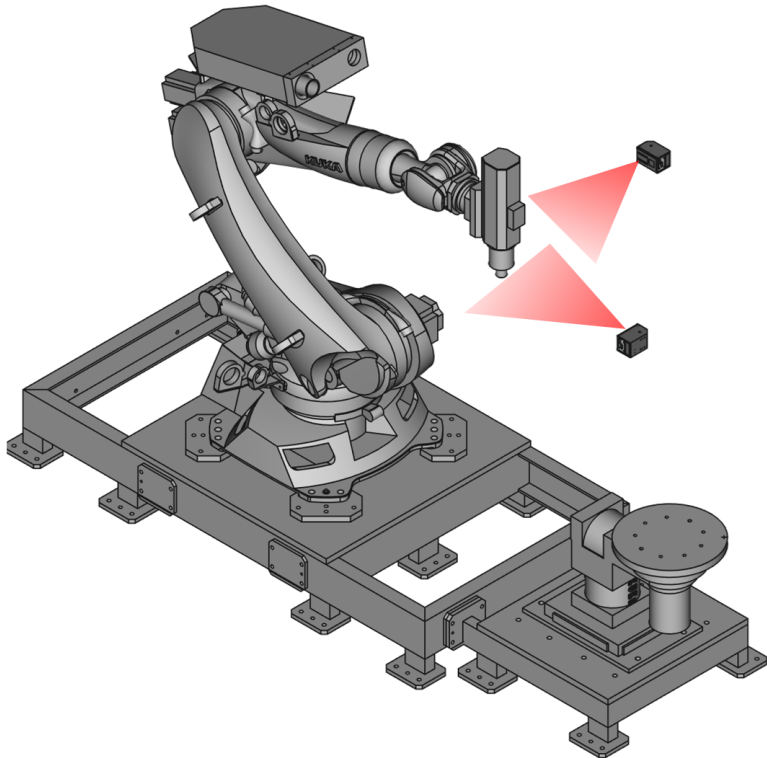
LAMM Operation



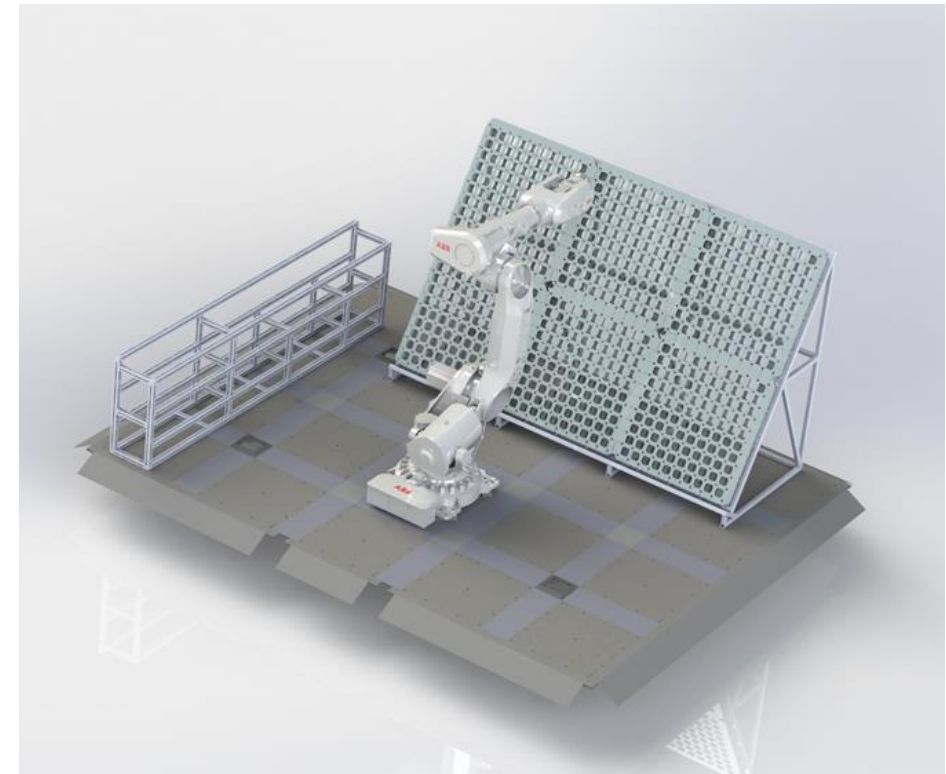
Applications for High Value Manufacturing

Investigations with AMRC provided 2 potential applications:

Real-time robot tracking

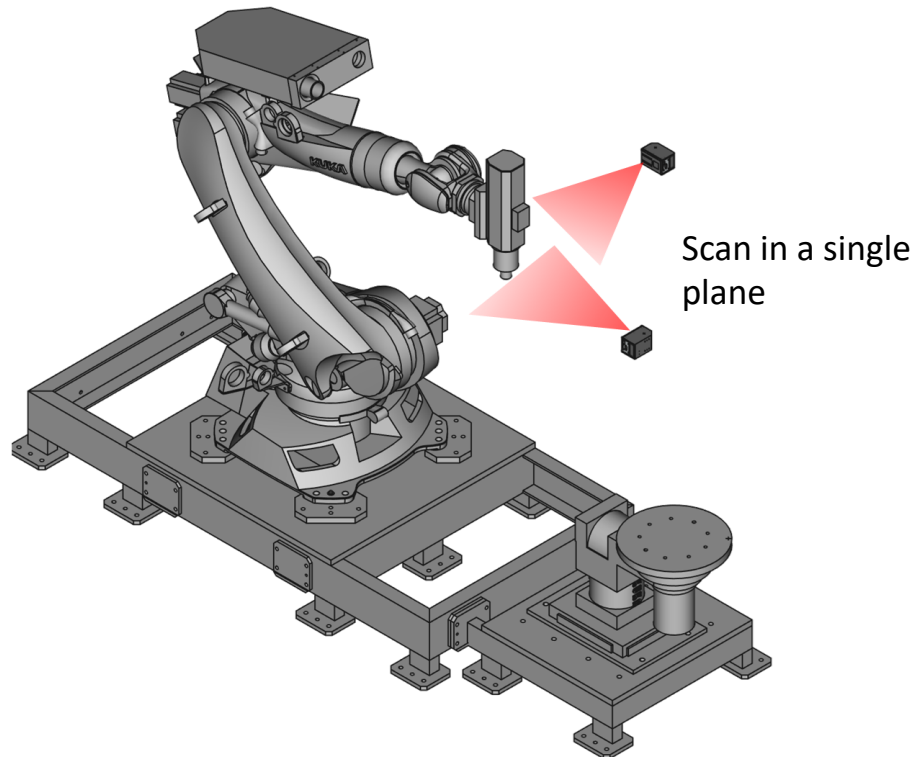


Assembly fixture verification

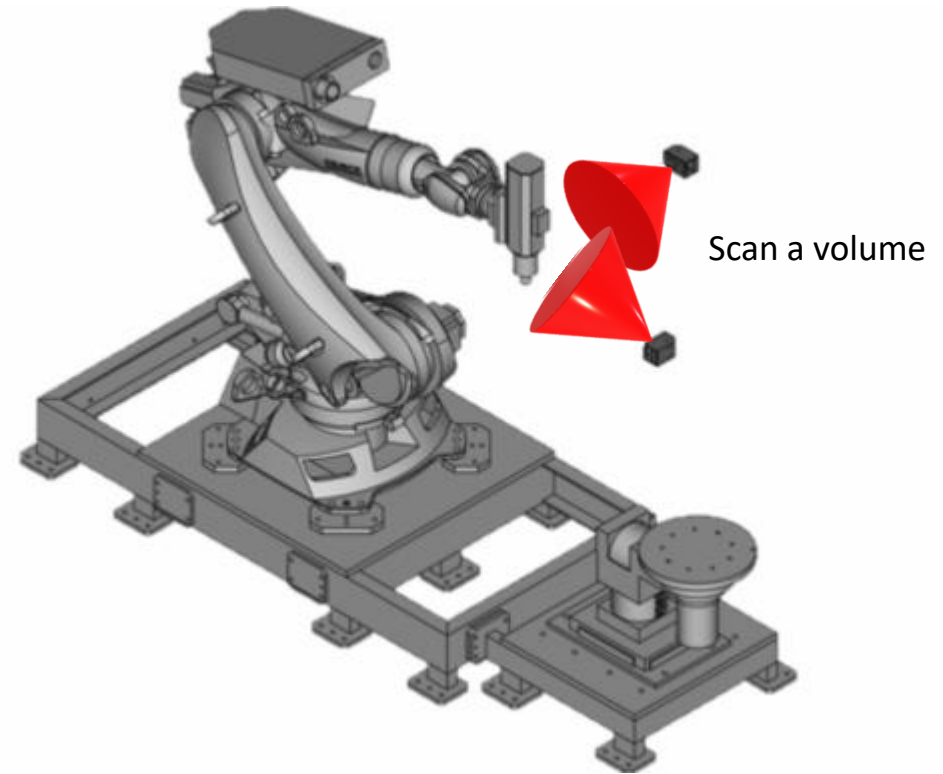


LAMM vs O-LAMM

LAMM



O-LAMM



Comparison of technologies;

Parameter	O-LAMM	Photogrammetry	Laser Tracker
Sample Rate	500Hz, 256 targets	50Hz multiple targets	1000 Hz Single target
Accuracy at 5m	± 0.029mm	± 0.075mm	±0.032mm
Resolution	1.2 arc seconds	3 arc seconds	1.3 arc second
Latency	<200µs	>50ms	>50ms
Field of view	Dynamic, nominally 50° x 60°	Fixed 38° x 32° typical	360° x 130°
Range	30m	10m	80m
Control unit	None required	Laptop or PC	Laptop or PC
Max units	Limited only by network	1	1

Features and Benefits

Accuracy

Patented single axis source and reflector architecture and Ultra high speed time-averaged sampling

Stability

No drift seen over years of operation

Reduce downtime

Continuous monitoring of a manufacturing cell will instantly show any deviations in 3D space which can be corrected



Safety

Internal hardware monitoring with Auto laser shutoff

Modular

Plug and play out of the box with this fully scalable solution

LOW COST

Significantly lower cost than Photogrammetry or laser tracking systems



Opportunities for collaboration

- PLX are looking for Robotic integrators to participate in the O-LAMM development to help develop end applications and systems using the O-LAMM technology
- There will be opportunities to develop kit parts such as calibration/verification tools etc to go with the O-LAMM
- PLX can offer expertise in precision laser beam steering/scanning/manipulation using MEMS devices and are looking for further applications for this technology

Thank You for Listening

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